Docket No.: 8733.884.00-US

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Byeong-Koo Kim, et al

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: June 26, 2003

Examiner: Not Yet Assigned

For: APPARATUS FOR APPLYING OFF-STATE

STRESS TO P-MOS DEVICE

## **CLAIM FOR PRIORITY**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following prior foreign application filed in the following foreign country on the date indicated:

CountryApplication No.DateKorea, Republic of2002-58286September 26, 2002

In support of this claim, a certified copy of the said original foreign application will be filed at a later date.

Dated: June 26, 2003

Respectfully submitted,

Rebecca/Goldman Rudich Registration No.: 41,786

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Attorneys for Applicant